

 <p>INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)</p>				Docket Number (Optional) <b>(Z) 99038 P US</b>		Application Number <b>10/047,150</b>		
				Applicant(s) <b>Schöppach</b>				
				Filing Date <b>01/14/2002</b>		Group Art Unit <b>2872</b>		
<b>U.S. PATENT DOCUMENTS</b>								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>								
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<b>FOREIGN PATENT DOCUMENTS</b>								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES NO	
<b>RP</b>		<b>DE 43 26 762 A1</b>	<b>10/08/1993</b>	<b>Germany</b>	<b>G02B</b>	<b>5/08</b>		<b>✓</b>
<b>OTHER DOCUMENTS</b> <small>(Including Author, Title, Date, Pertinent Pages, Etc.)</small>								
<b>RP</b>		"A New Concept in Telescope Design SiC as the Only Material for Mirrors and Structure", Fruit and Bougoin, CNES International Conference on Space Optics, 2-3 December, 1997.						
		"High Stability Carbon/Carbon Telescope Structure", Bailly, Cournu, Capdepu, Leleu, Kornmann, and Pradier, CNES International Conference on Space Optics, 2-3 December, 1997.						
EXAMINER <b>Plus 2 [Signature]</b>				DATE CONSIDERED <b>5/2/05</b>				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								